

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:

Hiroyuki EBINUMA

GROUP: 1655

SERIAL NO: 10/531,321

FILED: April 14, 2005

EXAMINER: MI, QIUWEN

FOR: DEFRACTOSYLATION METHOD

**SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET**

Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the inventor's city of residence and his mailing address.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.  
Norman F. Oblon



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Thomas M. Cunningham, Ph.D.  
Registration No. 45,394

Customer Number

22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 06/04)

Paul J. Killos  
Registration No 58,014